

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Confirmation No.: 5657

David Abraham et al.

Serial No.: 10/680,260

Group Art Unit: 2814

Filing Date: October 8, 2003

Examiner: Anh D. Mai

For: **METHOD AND SYSTEM FOR PATTERNING OF MAGNETIC THIN FILMS
 USING CHEMICAL TRANSFORMATION**

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following documents cited in a Japanese Office Action in a counterpart foreign patent application and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Additionally, English language abstracts of the references are included herewith.

This citation does not constitute an admission that the reference is relevant or material to the claims. It is only cited as constituting related art of which applicants are aware.

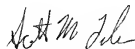
I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of that item by a foreign patent office in a counterpart foreign application, which occurred not more than three months prior to the filing of this statement.

It is respectfully requested that the listed reference be considered by the Examiner and formally made of record in this application.

Serial No.: 10/680,260
Docket No.: YOR8920030013US1

Please charge any deficiencies in fees and credit any overpayment of fees to Assignee's
Deposit Account No. 50-0510.

Respectfully submitted,



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Date: October 9, 2007
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